

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takashi OHSAKO et al.

Serial No. 10/677,221

Filed October 3, 2003

METHOD OF MANUFACTURING
SEMICONDUCTOR ELEMENT



: **Confirmation No. 8585**

: Docket No. 2003_1364A

: Group Art Unit 2823

: Examiner Joannie Garcia

: **Mail Stop: Amendment**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
March 9, 2005.

The fee of \$1,020.00 is

☒ submitted herewith.

☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

☐ Small entity status of this application is established by a Small Entity Status Assertion
which

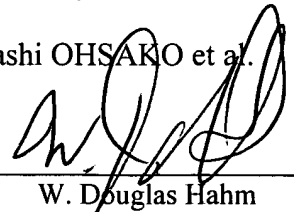
☐ is enclosed.

☐ has been previously submitted.

Respectfully submitted,

Takashi OHSAKO et al.

By


W. Douglas Hahm
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09/12/2005 JADD01 00000008 10677221

01 FC:1253

1020.00 US

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September 9, 2005